

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Applicant: MAJIMA et al.

Examiner: VO, Hai

FEB 18 2004

Serial No.: 09/890,550

Group No.: 1771

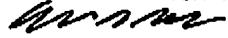
Filed: January 14, 2002

Title: POROUS SILICON CARBIDE SINTER AND SILICON CARBIDE-METAL
COMPOSITE THAT ARE OPTIMAL FOR A WAFER GRINDER TABLE

OFFICIAL

RESPONSE TO OFFICE ACTIONCERTIFICATE OF TRANSMISSION/MAILING

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Mark D. Passler Reg. No. 40,764

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In reply to the Office Action dated August 18, 2003 in the above-identified application,
please enter the following Response.

Remarks/Arguments begin on page 2 of this paper.